



Form 1449 (Modified)		Atty Docket No. NOVL085/NVLS-2875	Application No.: 10/785,235
Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)		Applicant: Wang et al. Filing Date February 23, 2004	Group 2812 2823

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
FLT	A1	4,882,008	1/21/89	Garza et al.			
FLT	A2	6,329,017	12/11/01	Lu et al.			
FLT	A3	2004/0099952	05/27/04	Goodner et al.			
FLT	A4	2004/0102031	05/27/04	Kloster et al.			
FLT	A5	2004/0185679	09/23/04	Ott et al.			
	A6						
	A7						
	A8						
	A9						
	A10						
	A11						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	B1							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
FLT	C1	Tipton et al., "Method For Removal Of Porogens From Porous Low-K Films Using Supercritical Fluids", U.S. Patent No. 10/672,305, filed September 26, 2003, Office Action dated March 22, 2005
Examiner	/Fernando L. Toledo/	Date Considered 11/14/2006

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form 1449 (Modified)**Information Disclosure
Statement By Applicant**

(Use Several Sheets if Necessary)

Atty Docket No.

NOVLP085/NVLS-002875 Unassigned 10/28/05, 235

Application No.:

Applicant:

Wang et al.

Filing Date

HEREWITH 2/23/04

Group

2823
Unassigned**U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
FLT	A1	6,329,017	12/11/01	Liu et al.			
	A2	6,383,466	5/7/02	Domansky et al.			
	A3	6,365,266	4/2/02	MacDougall et al.			
	A4	5,504,042	4/2/96	Cho et al.			
	A5	5,858,457	1/12/96	Brinker et al.			
	A6	6,270,846	8/7/01	Brinker et al.			
	A7	6,387,453	5/14/02	Brinker et al.			
	A8	6,420,441	10/10/99	Allen et al.			
	A9	6,271,273	10/10/00	You et al.			
	A10	4,885,262	12/5/89	Ting et al.			
	A11	5,686,054	11/11/97	Barthel et al.			
	A12	5,851,715	12/22/98	Barthel et al.			
	A13	6,140,252	10/31/00	Cho et al.			
	A14	6,392,017	5/21/02	Chandrashekhar			
	A15	6,386,466	5/14/02	Ozawa et al.			
	A16	4,357,451	11/2/82	McDaniel			
▼	A17	6,479,374	11/12/02	Ioka et al.			
	A18	6,548,113	4/15/03	Birnbaum et al.			

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation
							Yes
	B1						No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
FLT	C1	Liu et al., "Mesoporous Silica Film From a Solution Containing a Surfactant and Methods of Making Same," U.S. Patent Application Publication No. US2002/0034626, Published March 21, 2002, 27 Pages
FLT	C2	Wu et al., "Use of Multifunctional SI-Based Oligomer/Polymer for the Surface Modification of Nanoporous Silica Films," U.S. Patent Application Publication No. US2002/0001973, Published January 3, 2002, 13 Pages
FLT	C3	Cho et al., "Plasma Treatments of Molecularly Tempered Nanoporous Silica Films," Electrochemical and Solid-State Letters, 4 (4) G35-G38 (2001)

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FLT	C4	Justin F. Gaynor, "In-Situ Treatment of Low-K-Films-With-a Silylating Agent After Exposure To Oxidizing Environments," U.S. Patent Application No.10/056,926 filed January 24, 2002, 34 Pages
FLT	C5	Gangpadhyay et al., "The First International Surface Cleaning Workshop," Northeastern University, November 11-14, 2002
FLT	C6	Yung et al., "Spin-on Mesoporous Silica Films with Ultralow Dielectric Constants, Ordered Pore Structures, and Hydrophobic Surfaces," Adv. Mater. 2001, 13, No. 14, 1099-1102
FLT	C7	Schulberg et al., "System for Deposition of Mesoporous Materials," U.S. Patent Application No. 10/295,965, filed November 15, 2002, 64 Pages
FLT	C8	Watkins et al., "Mesoporous Materials and Methods," U.S. Patent Application No.10/301,013, filed November 21, 2002, 34 Pages
Examiner	/Fernando L. Toledo/	
	Date Considered 11/14/2006	

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